PTO/SB/21 (08=03)

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200			Applica	ation Number	09/	418,818	
TRANSMITTAL FORM			Filing [Date	Oc	tober 15, 1999	
			First N	amed Inventor	Ch	eung, David	
(to be used for all corres	oondence after ir	nitial filing)	Art Uni	t	176	63	
(to be used for all corres			Examiı	ner Name	Ru	dy Zervigon	
Total Number of Pages in Submission	Total Number of Pages in This			ey Docket Number	AN	M1084D01/T9320	
ENCLOSURES (Check all that apply)							
Fee Transmittal Form	1	☐ Drawin	g(s)			After Allowance Communication to Group	
Fee Attached		Licensi	ing-relate	d Papers		Appeal Communication to Board of Appeal and Interferences	
Amendment/Reply		Petition	1			Appeal Communication to Group (Appeal Notice, Brief, Reply Brief)	
After Final			n to Conv onal Appl			Proprietary Information	
Affidavits/declar				ey, Revocation espondence Address		Status Letter	
Extension of Time Request			al Disclai	mer		Other Enclosure(s) (please identify below):	
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Information Disclosur	☐ Information Disclosure Statement				Cop	pies of 10 cited references	
Certified Copy of Prior Document(s)	Certified Copy of Priority Document(s) Rema		rks	The Commissioner is Account 20-1430.	autho	rized to charge any additional fees to Depos	
Response to Missing	Response to Missing Parts/						
Response to Mi	Response to Missing Parts under 37 CFR 1.52 or 1.53					ŧ	
	SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT						
Firm Townsend and Crew LLP							
or Individual Ch	I Chun Day Launa Pag No. 41 405						
Signature / C/full							
Date 4_22 -04							
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TOWNSEND and TOWNSEND and CREWILP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

David Cheung et al.

Application No.: 09/418,818

Filed: October 15, 1999

For: METHOD AND APPARATUS FOR

DEPOSITING ANTIREFLECTIVE

COATING

Examiner: Rudy Zervigon

Art Unit: 1763

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT UNDER 37

Attorney Docket No.: AM1084D01/T9320

AMAT No.: 1084D01T9320

TTC No.: 016301-009320US

CFR §1.97 and §1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

David Cheung et al.

Application No.: 09/418,818

Page 2

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Respectfully submitted,

Chun-Pok Leung Reg. No. 41,405

TOWNSEND and TOWNSEND and CREW LLP

Tel: 650-326-2400 Fax: 415-576-0300

RL:rlj 60196774 v1 Substitute for form 1449B/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet	3	of	3	

Complete if Known					
Application Number	09/418,818				
Filing Date	October 15, 1999				
First Named Inventor	Cheung, David				
Art Unit	1763				
Examiner Name	Rudy Zervigon				
Attorney Docket Number	AM1084D01/T9320				

U.S. PATENT DOCUMENTS+						
	Document Number					
Examiner Initials*	Cite No.1	Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	1	US 4,089,992	05-16-1978	Doo , et al.		
	2	US 4,118,539	10-03-1978	Hirai , et al.		
	3	US 4,279,947	07-21-1981	Goldman , et al.		
	4	US 4,395,438	07-26-1983	Chiang		
	5	US 4,435,898	03-13-1984	Gaur, et al.		
	6	US 4,717,602	01-05-1988	Yamazaki		
	7	US 4,877,651	10-31-1989	Dory		
	8	US 4,894,352	01-16-1990	Lane, et al.		
	9	US 5,932,286	8-13-1999	Beinglass, et al.		

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No.1	Fore	eign Patent Doo	Cument Kind Code ⁶ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁵
		Country Code	Hamber	Killa Code (II Kilowii)			i igai os r ppour	

		NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²
	10	Johnson et al. Characterization of LPCVD of Silicon Nitride in a Rapid Thermal Processor, Mat. Res. Soc. Symp. Proc. 146:345-350 (1989)	

Examiner	:	Date	
Signature		Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). Applicant is to place a check mark here if English language Translation is attached.